

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 118749		APPLICATION NO. New US Application	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANTS Isao YOKOKAWA et al.			
				FILING DATE February 23, 2004			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME		CLASS	SUB CLASS
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY		CLASS	SUB CLASS
<i>CAC</i>	1	JP A 11-307472 (with abstract and translation)	11/05/1999	Japan			
<i>CAC</i>	2	JP A 5-211128 (with abstract and translation)	08/20/1993	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
	3	Eltran et al, "Science in Silicon", Surface Science Technology Series, Realize Inc., pp 443-496					
EXAMINER 				DATE CONSIDERED <i>6/8/05</i>			

Date: February 23, 2004